

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1406	(scan\$4 or raster\$3) same irradiat\$3 same block\$3	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/02/05 04:47
S2	124	(scan\$4 or raster\$3) same irradiat\$3 same block\$3 and gate electrode	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 15:04
S3	108	(scan\$4 or raster\$3) same irradiat\$3 same block\$3 and gate electrode and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/02/05 04:49
S4	35	(scan\$4 or raster\$3) with direction same irradiat\$3 same block\$3 and gate electrode and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 15:41
S5	1	("20050037552").PN.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/08/03 13:37
S6	2086	(438/149).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/02/05 06:38
S7	194	(438/150).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/02/05 06:38

S8	1565	(438/151).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/02/05 06:38
S9	2	("20050245007").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 15:06
S10	2	("6911358").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 15:08
S11	2	("20050277028").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 15:14
S12	2	("6700096").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 15:34
S13	2	("20050037552").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 15:34
S14	690	(scan\$4 or raster\$3) with (beam or irradiation or laser) and mirror and gate electrode same mask	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 15:43
S16	133	(scan\$4 or raster\$3) with (beam or irradiation or laser) same mirror and gate electrode same mask and tft	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 16:17

S17	2	("7078322").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 15:54
S18	2	("20040209410").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 16:25
S19	0	S18 and vibrates	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 15:55
S20	1	S18 and vibrates	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 15:55
S21	3	(scan\$4 or raster\$3) with (beam or irradiation or laser) same mirror and gate electrode same mask and tft and vibrate	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 16:03
S22	2	("20030166315").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 16:03
S23	18	(scan\$4 or raster\$3) with (beam or irradiation or laser) same mirror and gate electrode same mask and tft and vibrat \$3	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/06/06 16:19
S24	2	("6506635").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/06 16:19

S25	2	("7220627").PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/08/03 12:49
S26	627	(scan\$4 or raster\$3) with (beam or irradiation or laser) and mirror and gate electrode same mask and tft	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/08/03 13:36
S27	586	azami.in.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2007/08/03 13:37
S28	1986	(scan\$4 or raster\$3) with (beam or irradiation or laser) and gate electrode same mask	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/18 20:59
S29	165	(scan\$4 or raster\$3) with (beam or irradiation or laser) same mirror and gate electrode same mask and tft	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/18 20:59
S30	16	(scan\$4 or raster\$3) same irradiat\$3 same block\$3 with direction and gate electrode and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/18 20:59
S31	13	(scan\$4 or raster\$3) same irradiat\$3 same laser same block\$3 with direction and gate electrode and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/18 21:00
S32	0	(scan\$4 or raster\$3) same irradiat\$3 same beam same block\$3 with direction and gate electrode and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/18 21:08

S33	13	(scan\$4 or raster\$3) same irradiat\$3 same beam same block\$3 with direction and gate electrode and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/18 21:08
S34	191	(scan\$4 or raster\$3) with (beam or irradiation or laser) and tft and shadow mask	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 00:25
S35	20	(scan\$4 or raster\$3) with (beam or irradiation or laser) same shadow mask and tft	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 00:27
S36	3	"20050245007"	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 00:28
S37	9	"6506635"	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 00:44
S38	20	"6700096"	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 00:46
S39	9	"6,506,635"	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:25
S40	0	"6,506,635" and yag	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:40

S41	8	"6,506,635" and laser	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:40
S42	5	"6,506,635" and argon with laser	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:42
S43	1	galvanometer mirror	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:46
S44	3090	galvanometer mirror	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:46
S45	83	galvanometer mirror and laser and tft and block\$3	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/02/19 01:46
S46	2464	(438/149).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/19 02:24
S47	228	(438/150).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/19 02:24
S48	1810	(438/151).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/02/19 02:24

S49	2588	(438/149).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/29 14:58
S50	1975	(438/151).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/29 14:58
S51	1362	(438/795).CCLS.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/29 14:58
S52	534	block\$3 plate and laser and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/08/29 15:02
S53	223	block\$3 plate and laser same scan\$4 and semiconductor	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/08/29 15:03
S54	17	block\$3 plate and laser same scan\$4 and semiconductor and gate electrode	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/08/29 15:03
S55	1031	tanaka-koichiro.in.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/08/29 15:27
S56	482	tanaka-koichiro.in. and laser and semiconductor and scan\$4	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/08/29 15:27

S57	0	"5,756,364" "5,815,494" "5,932,118" "6,087,277" "6,246,524" "6,322,625" "6,341,042" "6,429,100" "6,495,405" "6,528,758" "6,573,163" "6,777,276" "6,897,889" "6,984,573" "7,078,281" "7,164,152"	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2008/08/29 15:28
S58	32	(("5,756,364") or ("5,815,494") or ("5,932,118") or ("6,087,277") or ("6,246,524") or ("6,322,625") or ("6,341,042") or ("6,429,100") or ("6,495,405") or ("6,528,758") or ("6,573,163") or ("6,777,276") or ("6,897,889") or ("6,984,573") or ("7,078,281") or ("7,164,152")).PN.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/29 15:29
S59	369	(257/e21.561).CCLS.	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/29 15:32

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